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 FILING OR 371 (c) DATE
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 10/805,323
 03/22/2004
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CONFIRMATION NO. 9102

FILING RECEIPT

OC000000012839898

C000000012839898

Data Ma

Date Mailed: 06/03/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply

to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

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Assignment For Published Patent Application

Canon Kabushiki Kaisha, Tokyo, JAPAN;

Domestic Priority data as claimed by applicant

Foreign Applications

JAPAN 2003-018783 03/25/2003 JAPAN 2003-081785

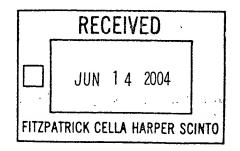
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If Required, Foreign Filing License Granted: 06/01/2004

Projected Publication Date: 09/30/2004

Non-Publication Request: No

Early Publication Request: No



Title

Zinc oxide film treatment method and method of manufacturing photovoltaic device utilizing the same

Preliminary Class

438

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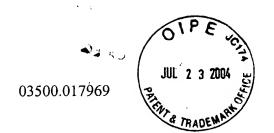
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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Appl	ication of:)	
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MASUMI	TSU IWATA, ET AL.)	Group Art Unit: 1753
Application No.: 10/805,323))	Group Fut Omt. 1733
D'1 1 3 6	1.00.0004	:	
Filed: March 22, 2004)	
For: ZII	NC OXIDE FILM TREATMENT)	
MI	ETHOD AND METHOD OF	:	
MA	ANUFACTURING)	
PH	OTOVOLTAIC DEVICE	:	
UI	ILIZINĢ THE SAME)	July 23, 2004

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

REQUEST FOR CORRECTED FILING RECEIPT

Sir:

Applicants have received an official Filing Receipt which contains the incorrect foreign priority information. In particular, "JAPAN 2003-018785" should read --JAPAN 2003-081785--, as shown in red on the attached marked-up copy of the Filing Receipt.

Issuance of a corrected Filing Receipt is respectfully requested.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants Damond E. Vadnais Registration No. 52,310

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